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10/629,742

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

*Entered by
RCE on
05/04/07*

In the Patent Application of

Alfred I-Tsung Pan et al.

Application No. 10/629,742

Filed: July 30, 2003

For: Stereolithographic Method and
Apparatus for Forming Three-
Dimensional Structure

Group Art Unit: 1732

Examiner: Lambelet, Lawrence E.

AFTER-FINAL RESPONSE

UNDER 37 C.F.R. § 1.116

Commissioner for Patents
Mail Stop Amendment
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Commissioner:

In response to the final Official Action mailed on December 5, 2006, please consider the following.